



THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

**GOTO, Takenori**

Group Art Unit: **2815**

Serial No.: **09/888,419**

Examiner: **NGUYEN, Joseph H.**

Filed: **June 26, 2001**

P.T.O. Confirmation No.: **9498**

For: **NITRIDE BASED SEMICONDUCTOR LASER DEVICE AND METHOD OF  
FABRICATING THE SAME**

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Date: June 3, 2003

Sir:

In response to the Office Action dated March 3, 2003, please amend the above identified application as follows:

RECEIVED  
JUN -4 2003  
TECHNOLOGY CENTER 2800